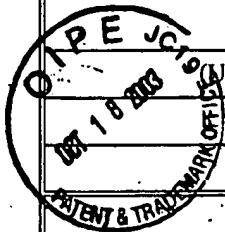


U.S. Department of Commerce, Patent and Trademark		Atty. Docket No.	Application No.
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		TNCR.178US2	10/791,026
		Applicant(s)	Conf. No.
(Use several sheets if necessary)		Wayne Chen et al.	1277
		Filing Date	Group
		March 1, 2004	2877



## U.S. Patent Documents

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
W	1	4,449,818	May 22, 1984	Yamaguchi, et al.			
W	2	5,301,129	Apr., 1994	McKaughan et al.			
W	3	5,699,447	Dec., 1997	Alumot et al.			
W	4	5,808,735	Sep., 1998	Lee et al.			
W	5	5,864,394	Jan., 1999	Jordan, III et al.			
W	6	5,907,628	May, 1999	Yolles et al.			
W	7	5,991,699	Nov., 1999	Kulkarni et al.			
W	8	6,195,444	Feb., 2001	Simanovsky et al.			
W	9	6,201,601	Mar., 2001	Vaez-Iravani, et al.			
W	10	6,266,437	Jul., 2001	Eichel et al.			

## U.S. Published Patent Application Documents

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate

## Foreign Patent Documents

		Document	Date	Country	Class	Subclass	Translation	Yes	No

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

W	11	"Acoustic Scanners and Modulators," M. Gottlieb, Optical Scanning, ed. by Gerald F. Marshall, Dekker 1991, pp. 615-685.
W	12	"CMP Applications for Sub-0.25.micron Process Technologies," D. Pramanik et al., presented at Electrochemical Society Proceedings: Chemical Mechanical Planarization in IC Device Manufacturing (2.sup.nd International Symposium), vol. 98-7, 1998.
W	13	Integrated CMP Defect Monitoring Strategy," W. Chen et al., presented at The Electrochemical Society Proceedings: Chemical Mechanical Polishing in IC Device Manufacturing III, Editors: V.A. Arimoto et al., PV99-37, Honolulu, Oct. 1999.

Examiner Michael S. Date Considered 11-15-04

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.